

CS03-028



Application No. 10/828,887

IFW

December 7, 2006

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Stephen B. Ackerman, Reg. No. 37, 761
28 Davis Avenue
Poughkeepsie, NY 12603

Subject: Application No. 10/828,887 21 April 2004

Yisuo Li et al.

A Method of Forming an Inductor with Continuous Metal Deposition

Art Unit: 2822 Examiner: Toniae M. Thomas


RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated October 19, 2006, please amend the above identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, PO Box 1450, Alexandria, VA 22313-1450, on January 19, 2007.


Stephen B. Ackerman
Reg. No. 37, 761

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this document

Remarks/Arguments begin on page 8 of this document.